

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Shunpei Yamazaki et al.                      Art Unit : 2822  
Serial No. : 10/730,047                                      Examiner : Roy Karl Potter  
Filed : December 9, 2003  
Title : SEMICONDUCTOR CHIP AND METHOD FOR MANUFACTURING THE  
SAME

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

REQUEST FOR INITIALED PTO FORM 1449

Upon reviewing the file, applicants noted that they received an initialed copy of the enclosed PTO Form 1449 that accompanied an information disclosure statement filed July 7, 2005. However, the Examiner inadvertently skipped an initial on Desig. ID "ABB".

It is respectfully request that the examiner initial and return this form as soon as possible. Note, applicants must pay the issue fee by April 20, 2006, so the examiner's prompt attention to this matter would be appreciated.

Respectfully submitted,

Date: 3/31/06

  
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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12732-185001	Application No. 10/730,047
<b>Information Disclosure Statement by Applicant</b> (Use several sheets if necessary)		Applicant <b>Shunpei Yamazaki et al.</b>	
		Filing Date <b>December 9, 2003</b>	Group Art Unit <b>2822</b>
(37 CFR §1.98(b))			

### U.S. Patent Documents

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2002/0131007 A1	09/19/2002	Yamazaki et al.			05/01/2002
	AB	2003/0025118 A1	02/06/2003	Yamazaki et al.			07/22/2002
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	AE	2003/0047732 A1	03/13/2003	Yamazaki et al.			07/31/2002
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	AG	2003/0082889 A1	05/01/2003	Maruyama et al.			10/30/2002
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	AAA	6,677,621 B2	01/13/2004	Yamazaki et al.			05/21/2001

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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(37 CFR §1.98(b))

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	ABB	6,830,494 B1	12/14/2004	Yamazaki et al.			10/06/2000

**Foreign Patent Documents or Published Foreign Patent Applications**

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							Yes	No
	ACC	10-125930	05/15/1998	JAPAN			AB	
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**Other Documents (include Author, Title, Date, and Place of Publication)**

Examiner Initial	Desig. ID	Document
	AHH	"Mass Production of Organic EL Devices"; <i>Shimotsuke Newspaper</i> , July 3, 2003 (full translation)
	AII	"Two-way display developed"; Newspaper <i>"The Japan Times"</i> , July 3, 2003
	AJJ	<i>Exhibition of Active Matrix Type Organic EL Display at "13<sup>th</sup> Flat Panel Display Manufacturing Technology Expo &amp; Conference"</i> by ELDis Group; July 2, 2003 (full translation)
	AKK	Documents distributed in the <i>"13<sup>th</sup> Flat Panel Display Manufacturing Technology Expo &amp; Conference"</i> by ELDis Group; July 2, 2003 (full translation)

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